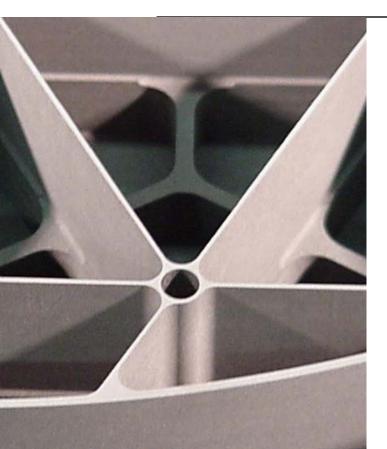
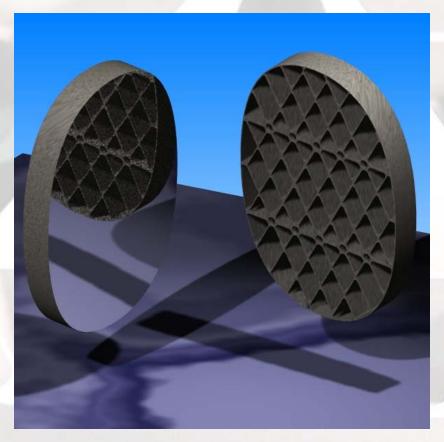
A Low-Cost Innovative Approach for the Fabrication of Net-Shape SiC Components for Mirror Substrates



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Opportunity



 Beryllium is being phased out due to mounting health concerns and cost.
 There is a need for a new replacement material with comparable properties desirable for optics applications.

SiC Mirror Substrates Recently Manufactured by POCO

Selection Criteria

- Property requirements as compared to beryllium such as specific stiffness, thermal stability, etc.
- Property Comparison of Candidate Materials
- Ease of Complex Net-Shape Manufacturing
- A Low Cost Manufacturing Process

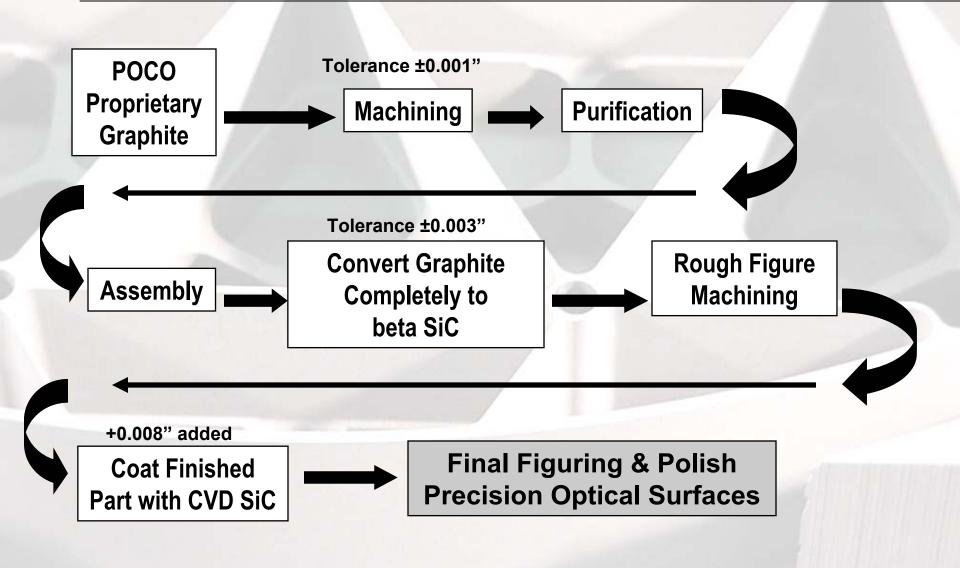
Property Requirements for Materials in Optics

| Low | High | Benefit | |
|--------------------|--|--|--|
| Density (ρ) | Elastic Modulus (E) | High Specific Stiffness (E/ _ρ) | |
| CTE (α) | Thermal Conductivity (κ) | High Stability Factor ($_{\kappa}/_{\alpha}$) | |
| | Thermal Diffusivity (D) & Heat Capacity (C) | High Thermal Conductivity | |
| Poisson's Ratio | Strength & Fracture Toughness | Long-Term Stability | |

Material Property Comparison

| Material | Density | Elastic | Thermal | Thermal | Specific | Thermal |
|--------------------------|---------------------|------------|-----------|--------------|-----------------------|-----------|
| | (ρ) | modulus | expansion | conductivity | Stiffness | Stability |
| | | (E) | (α) | (к) | (Ε /ρ) | Parameter |
| | | | | | | (κ/α) |
| Units | g/cm³ | GPa | x 10⁵/K | Wm-K | kN-m/g | Wμm |
| RB SiC | 2.92 | 310 | 24 | 157 | 106 | 65 |
| CVD SiC | 3.21 | 466 | 22 | 300 | 145 | 136 |
| HP SiC | 3.20 | 455 | 26 | 155 | 142 | 60 |
| Sintered SiC | 3.16 | 415 | 25 | 114 | 131 | 46 |
| Beryllium | 1.85 | 303 | 11.4 | 216 | 164 | 20 |
| Zerodur ® ⁽⁷⁾ | 2.53 | 91 | 0.05 | 1.64 | 36 | 33 |
| BK7 (glass) | 2.53 | 81 | 7.1 | 1.12 | 32 | 0.16 |
| SXA | 2.91 | 117 | 13.0 | 125 | 40 | 9.62 |
| Auminum | 27 | 68 | 23.6 | 170 | 25 | 7.20 |
| POCO SiC | 253 | 218 | 1.2 | 170 | 85 | 142 |

POCO SuperSiCTM Process



SUPERSiCTM Conversion Process

Purified, Net-Shape (Machined) Graphite

Polycrystalline, Stoichiometric ß-SiC



 $2C + SiO \rightarrow SiC + CO$

No Additives (High Purity)

POCO Manufacturing Capability

POCO has been supplying different industries with numerous SiC products, such as wafer carriers, of high purity and excellent mechanical and thermal properties



Advantages of POCO's Process

Manufacturing capability

- Near net-shape Consistent dimensional changes as a result of C \Rightarrow SiC conversion and CTE change
- High shape complexity due to ease of graphite machining -Comparable to Aluminum
- Low cost due to absence of tooling charges and post machining
- High purity due to absence of any additives
- Short lead time due to the unique nature of the process
- POCO engineers and produces own graphite for conversion to SiC
 - Continuous improvement
 - SiC properties can be controlled by controlling graphite properties
 - Quality control is under our control.

Objectives and Benefits of the Proposed Work

Objective:

◆ Develop a post process for the DENSIFICATION of POCO's porous SuperSiC[™] material <u>without</u> sacrificing near net-shape manufacturing capability.

Benefit:

 Capability of producing dense near net-shape SiC products with cost/performance attributes comparable to other commercially available SiC products.

Outline of the Proposed Process

- Produce the desired near net-shape porous SuperSiC[™] part using POCO's conversion process (No development needed)
- Impregnate the part with a carbon precursor mixture, the composition of which is to be developed in this Phase I; cure and pyrolyze
- Repeat impregnation cycle, if needed, ⇒ The result is a carbon structure with interconnected microporosity residing in the open pores of the part to be densified.
- Infiltrate with silicon to convert the carbon to SiC resulting in a net-shape dense SuperSiC densified with the new RFSC phase.
- Apply CVD SiC coating or silicon cladding, if needed.

Phase I Work Plan

- Define mirror requirements (Raytheon)
- Prepare porous SiC preforms and test specimens
- Select an array of resin compositions most suitable as the carbon precursor
- Develop impregnation conditions and prepare carbon-impregnated samples
- Develop silicon infiltration conditions
- Characterize RFSC-Densified samples for density, porosity, strength, stiffness, fracture toughness, thermal conductivity, CTE, microstructure & free Si
- Final technical report in addition to monthly progress reports

Some Preliminary Results as Compared to SuperSiCTM

| Property | | As-Converted (SuperSiC™) | SiC-Densified (Proposed) |
|---|--------------------|-----------------------------|------------------------------|
| Bulk Density, $\rho_{\rm b}$ (g/cm ³) | | 2.53 | 3.07 |
| Total Porosity, Pt (%) | | 20 | |
| Open Porosity, P _{op} (%) | | 18-19 | 0 |
| Flexural Strength (MPa/ksi) <i>m is Weibull modulus</i> @ RT | | 147/21.3 (m=17) | 200/29-275/40 (up 36-87%) |
| Tensile Strength (MPa/ksi) | 10 | 129/18.7 (m=16) | |
| Young's Modulus, E (GPa/msi) | | 218/32 | 375/54 (up 72%) |
| Specific Stiffness, E/pb (kN-m/g) | | 85 | 121 (up 42%) |
| Poisson's Ratio, v | | 0.17 | |
| Dynamic Shear Modulus, G (GPa | a/msi) | 96/14 | |
| Fracture Toughness, KIC (MPa.m | l ^{0.5}) | 2.3 | |
| Hardness (kg/mm ²) | | 2000 | |
| Thermal Conductivity, κ (W/m·K) | | 170 | |
| Moon Coofficient of Thormal | @ 500°C | 4.0 ⁽¹⁾ | |
| Mean Coefficient of Thermal Expansion (CTE), α_m (10 ⁻⁶ /K) | @ 1000°C | 4 .4 ⁽¹⁾ | |
| Expansion (CTE), α_m (TO /K) | @ 25 | 1.2 ⁽²⁾ | |

Further Development

- Demonstrate repeatability of the developed process
- Scale up the process for the densification of complex shapes and large parts
- Test the developed process for the manufacturing of SiC fiber-reinforced SiC matrix composites
- Demonstrate the CVD SiC coating of densified plates and their polishability
- Develop correlation between material properties and mirror performance

Commercialization and Other Applications

- POCO will continue to support the development of the proposed process and the commercialization of the produced SiC material
- In addition to optics, there is a definite need for a dense low-cost SiC material for a number of other applications such as in the semiconductor industry where corrosion resistance is desirable

Summary

- Silicon carbide is the material of choice to replace Beryllium
- POCO's process has the advantage of manufacturing capability to produce complex shape SiC products at lower cost
- POCO has the advantage of producing own graphite for conversion to SiC ensuring a continuous quality control
- Although POCO's SuperSiCTM material has good mechanical and thermal properties needed for optics and other applications, there is still room for improvement via the proposed densification process
- Preliminary results showed a significant increase in flexural strength and stiffness for the densified SiC material

Acknowledgement

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- POCO is looking forward to working with Dr. Arup Maji (Technical Monitor), AFRL/VSSV, Kirtland AFB, NM, and utilize his technical support and guidance towards achieving the objectives and goals of this project